



EM MICROELECTRONIC - MARIN SA

Accurate design of mixed-mode circuits by using advanced MOSFET modelling

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Outline:

- MOSFET models in use at EMM EKV2.6, EKV3.0
- Examples of design and modelling challenges (EKV2.6 → EKV3)
 - Leakage I_{off} in ultra low-power digital design
 - Accuracy of analog parameters around V_{th}
 - Good model of output conductance
 - Model of native MOST
 - NQS effects in long MOST
 - Model of 2T-flash cell
 - Other challenges: BIN continuity, IV, AC and CV accuracy, RF...



MOSFET models at EMM

EKV2.6 – EM’s own processes (1.0 μ m, 0.5 μ m, 0.35 μ m CMOS)

- many successful mixed-signal designs (with embedded E²)
- was good for analog and weak-inversion designs
- physical parameters, natural process corners, easy to adapt process change
- ELDO, SPECTRE
- HSIM (native implementation)

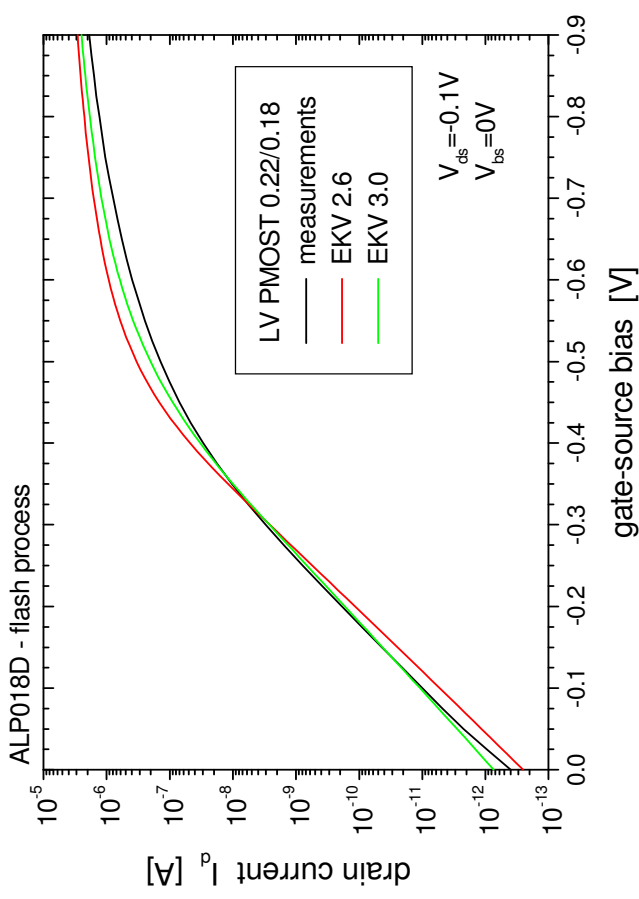
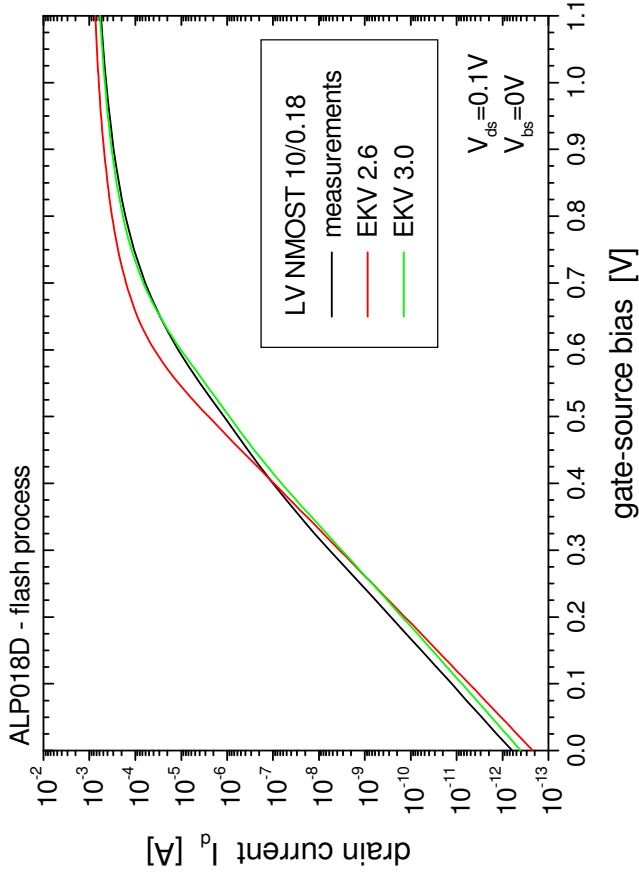
EKV3.0 – EM’s own processes 0.18 μ m logic and FLASH

- SPECTRE
- HSIM – no native implementation



Example: Leakage I_{off} in ultra low-power digital design

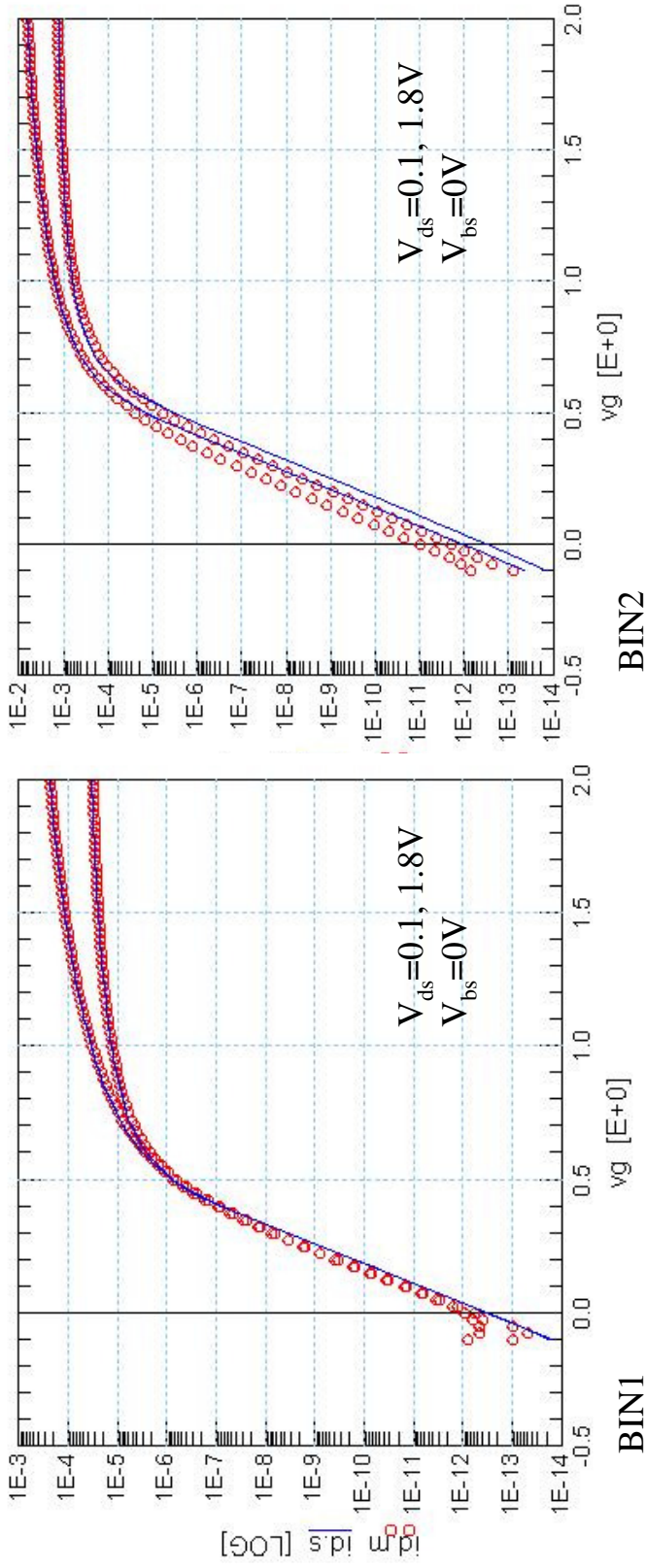
- accurate I_{off} model is important
- synthesis of digital block - minimizing I_{leak}
- 100kgates ~ 10-20nA (0.18 μ m/FLASH)



EKV2.6 for advanced processes: need compromises between I_{off} and weak-inv. accuracy



0.18μm FLASH experimental lot: LV NMOST (25°C)
10/10 10/0.18

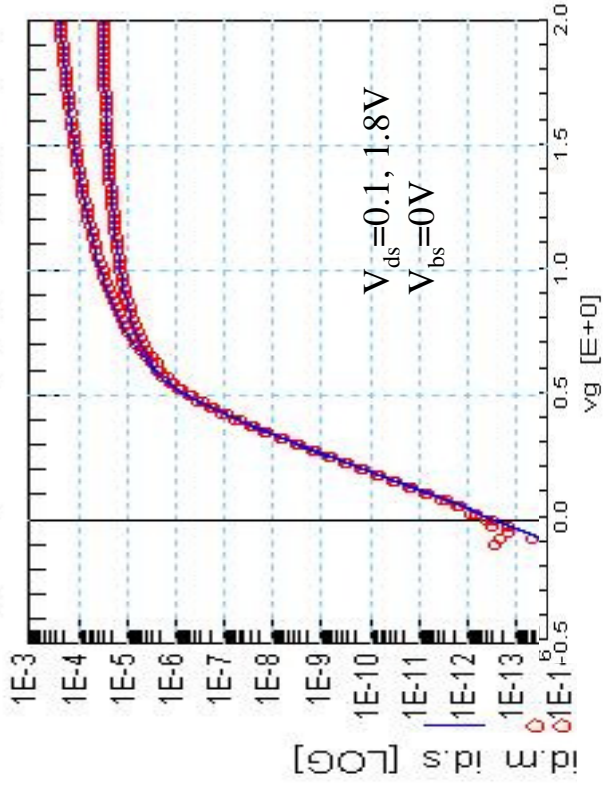


EKV 2.6

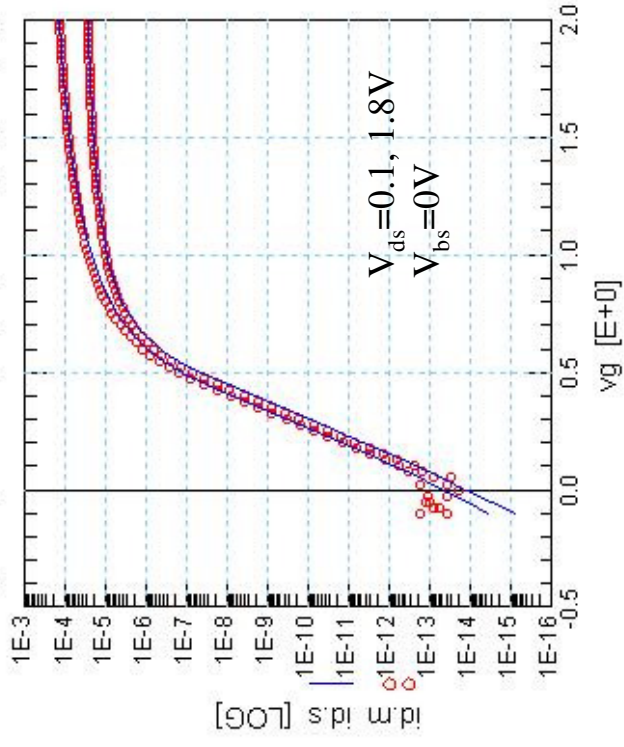


0.18 μ m FLASH: LV NMOST (25°C)

10/10



0.22/0.18

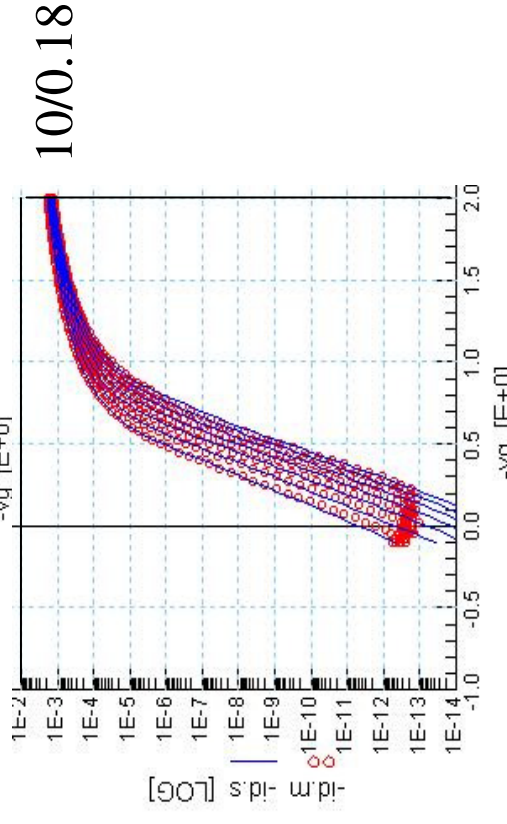
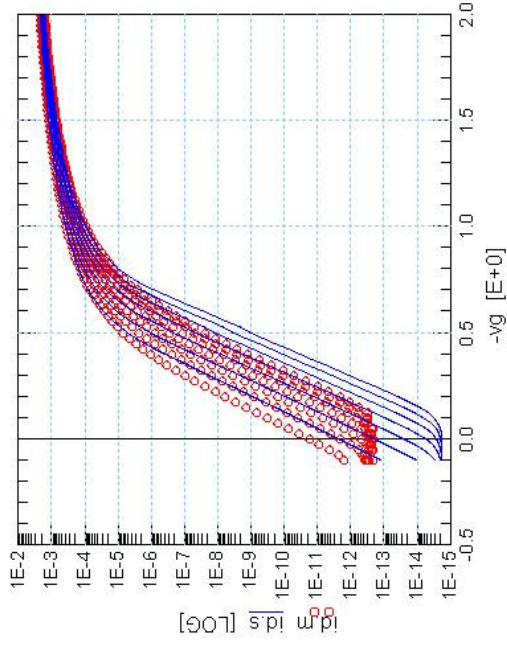
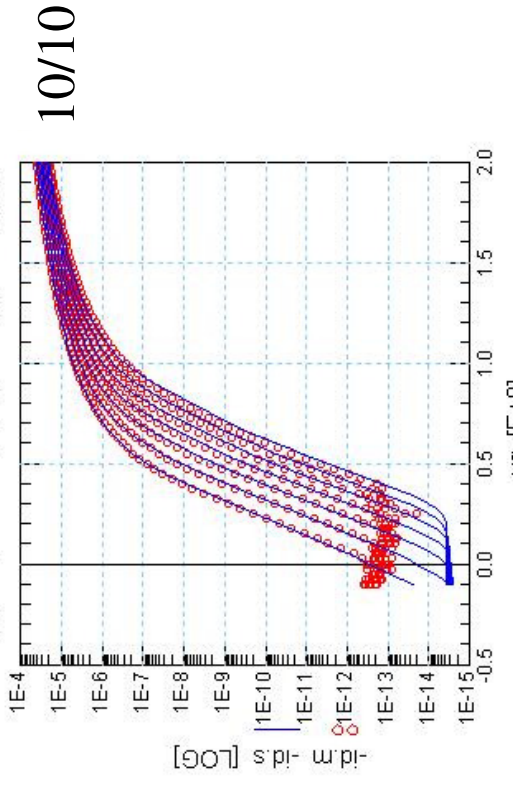
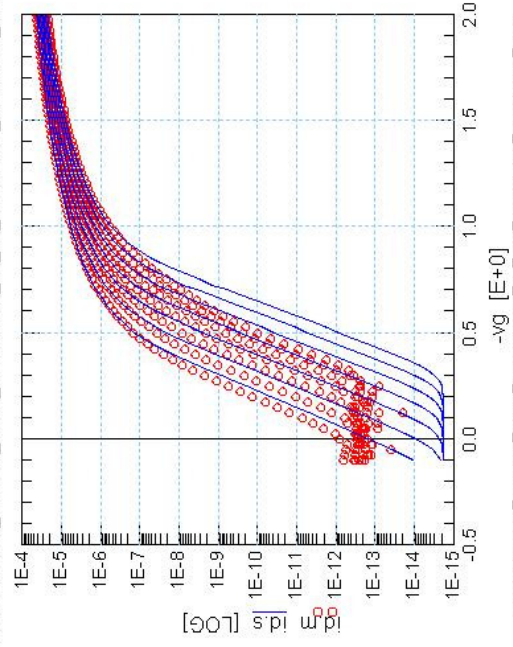


unique parameter set

EKV 3



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$V_{ds} = -1.8V$
 $V_{bs} = 0, 0.3, 0.6, 0.9, 1.2, 1.5, 1.8V$

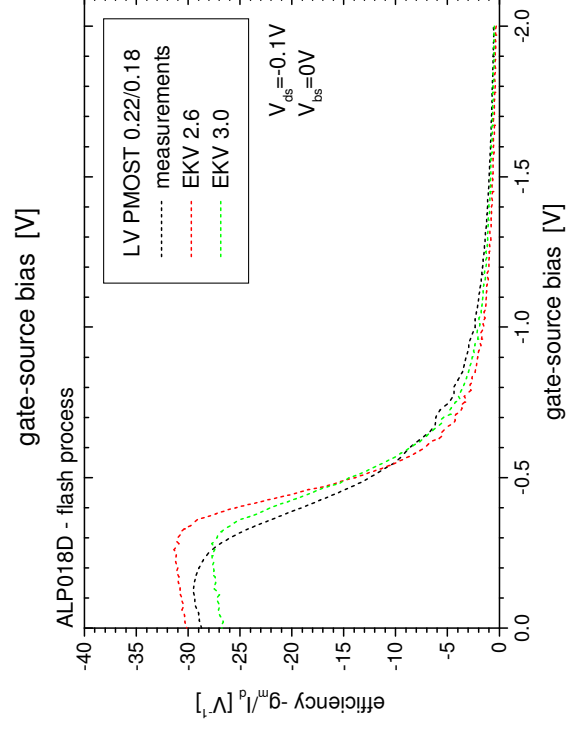
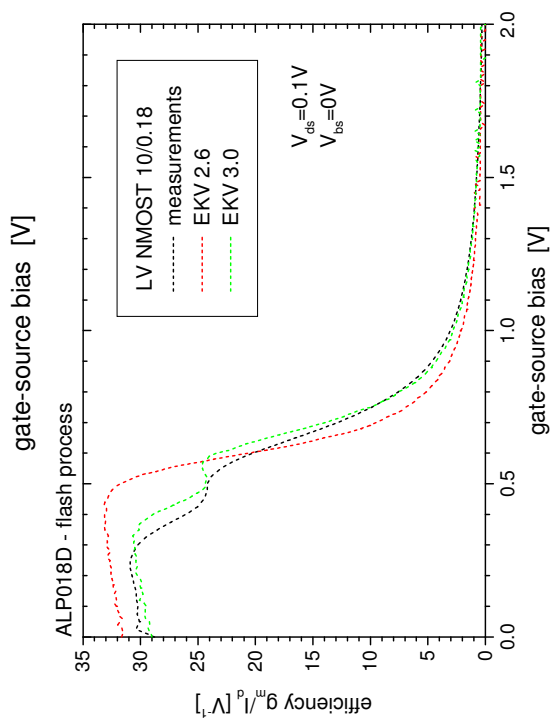
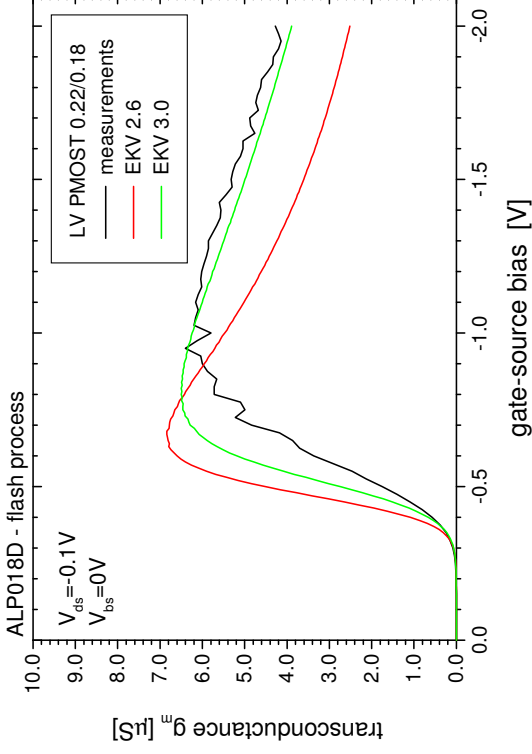
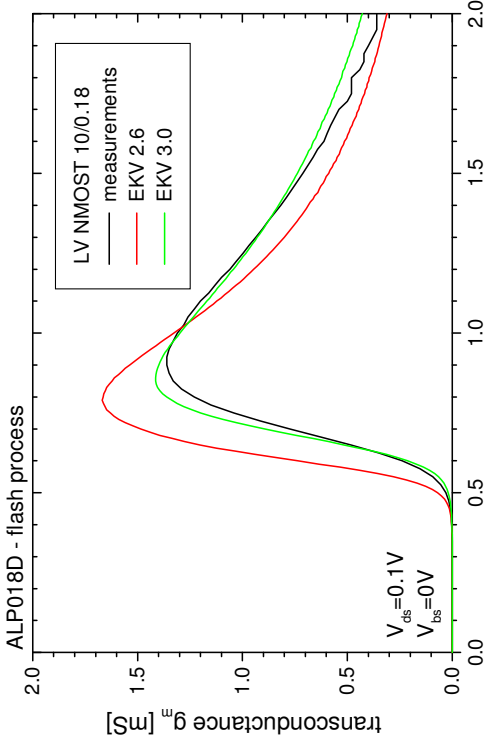
EKV2.6

EKV3

0.18 μ m FLASH: LV PMOST (25°C)



Example: Accuracy of analog parameters around V_{th}

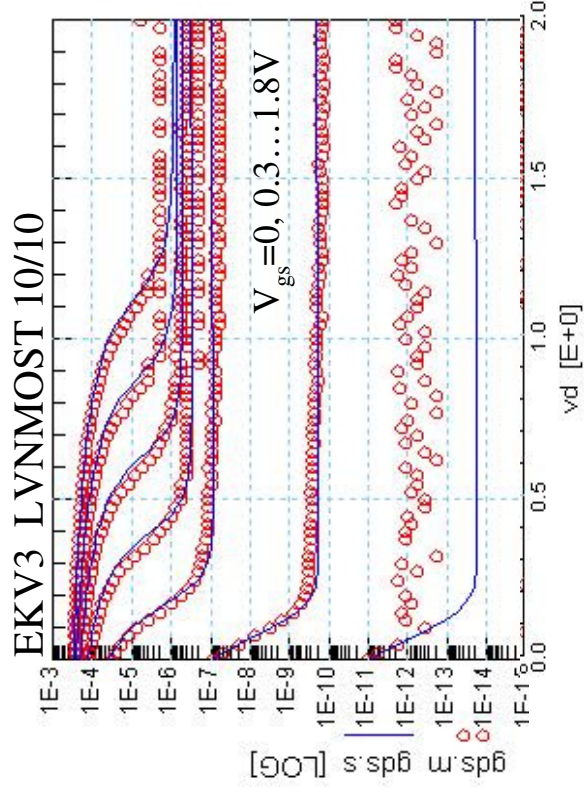
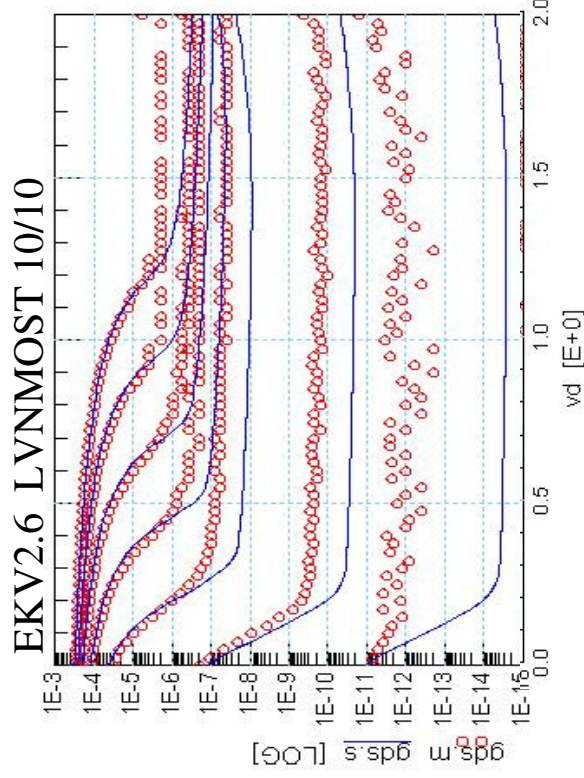


Example: good model of output conductance

- design of low-noise amplifier in 0.18 μm logic process
- long-channel MOST ($> 10\mu\text{m}$)

Conductance g_{ds} degrades in long-channel (of 0.18 μm EM processes)

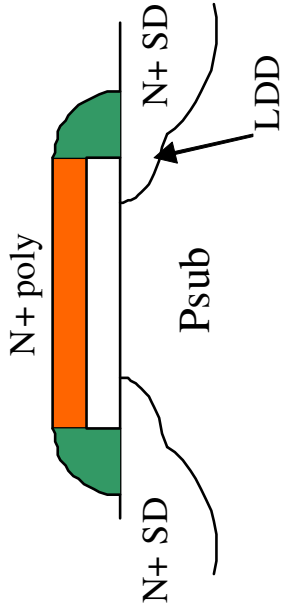
- LV MOST 1.8V (HALO implant)
- MV MOST 3.3V



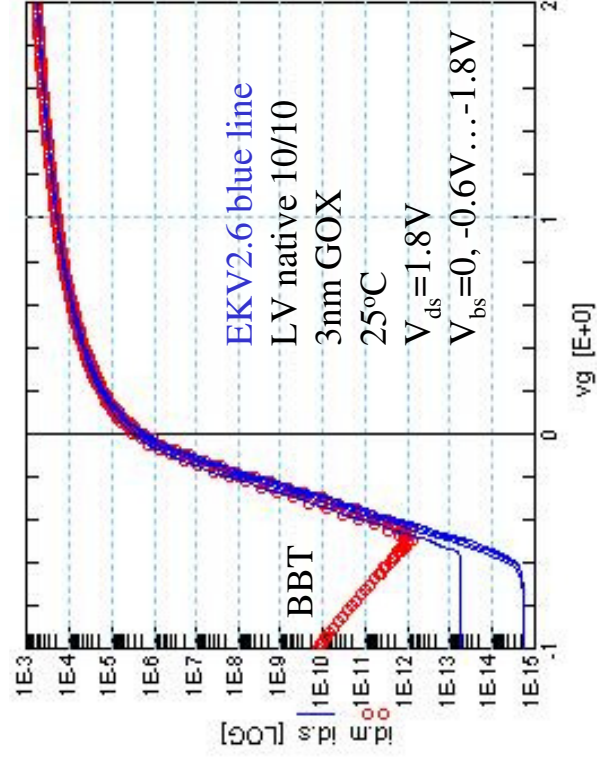
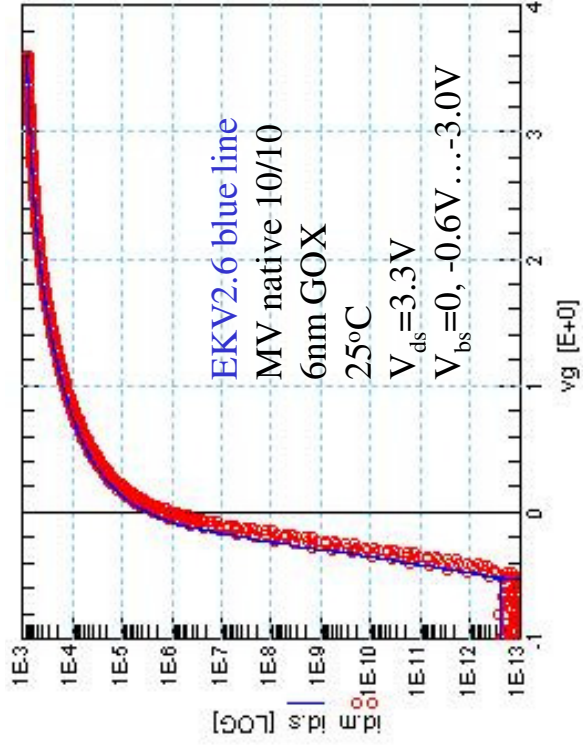
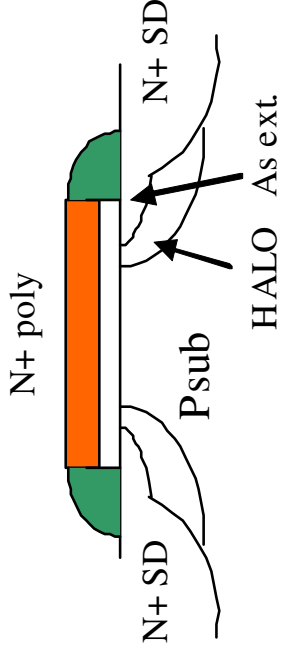
EKV2.6: parameters tuned for g_{ds} of short $L_G \Rightarrow g_{ds}$ strongly underestimated in long L_G in analog circuits
 Practical solution for EKV2.6: separate BIN for g_{ds} tuning of desired long L_G

Example: Model of native MOST

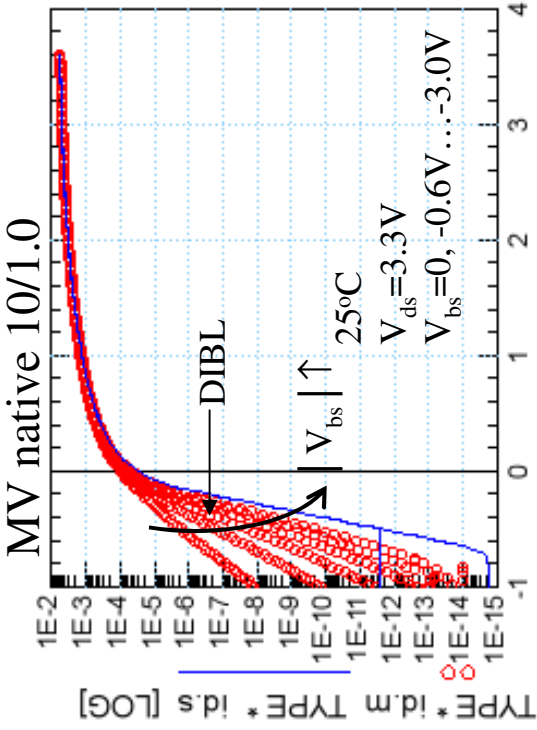
MV native 10/10



LV native 10/10

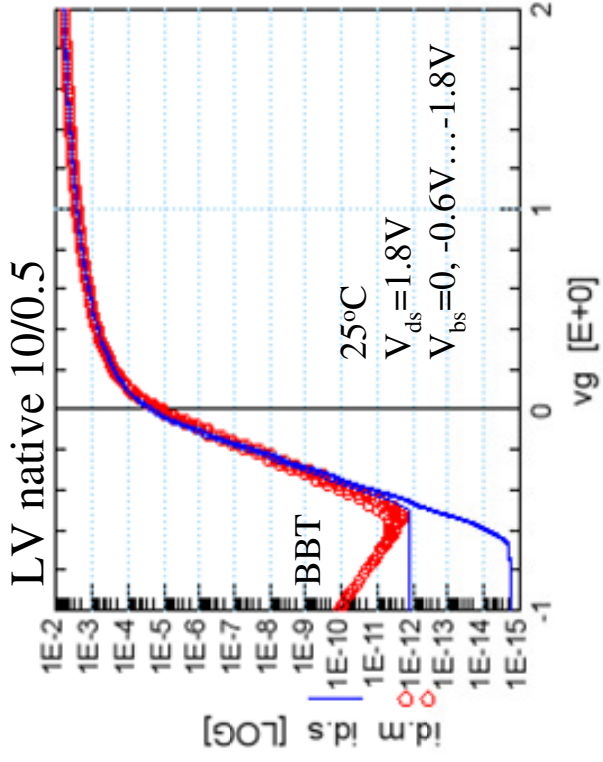
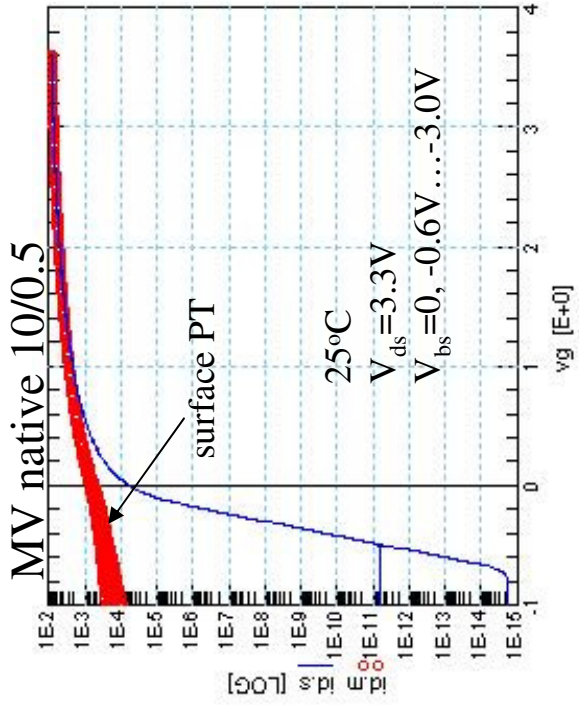


0.18 μ m logic process



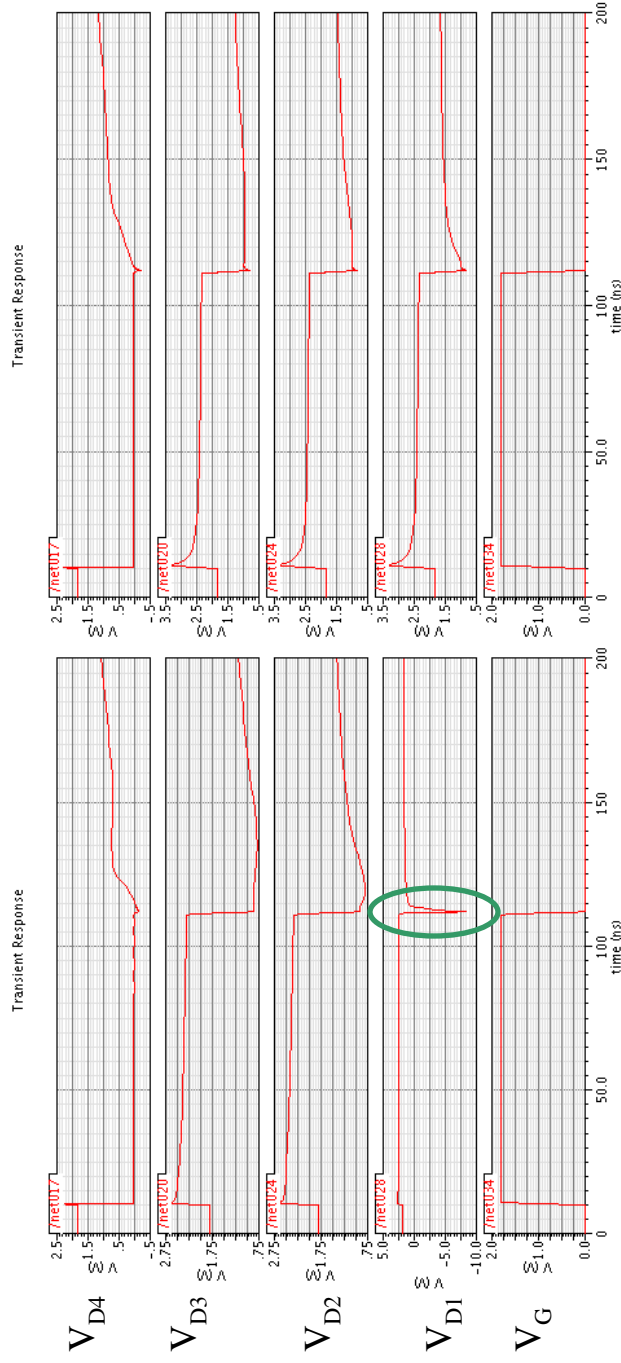
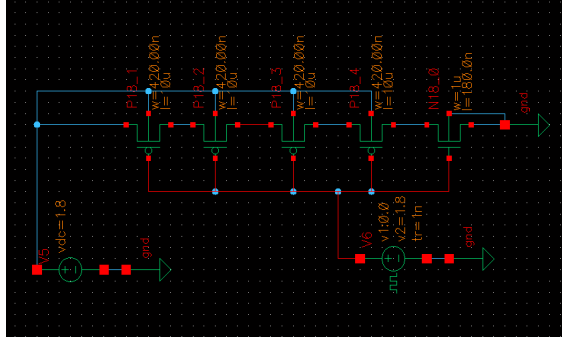
EKV2.6 blue lines

For short native at moderate/high V_{ds}
 Model EKV 2.6 fails due to:
 - DIBL effect
 - BBT



Example: Non-quasi-static effect in long MOST

- Known artefact of negative drain/source current spikes
- Fast switching of long MOST
- In EM practical design:
 - Turn-ON simulation of IC blocks
 - Control of analog part working in DC by core logic
- Artefact in MOST models that apply QS charge conservation



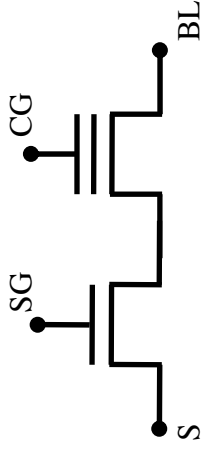
EKV2.6

EKV3_nqs



Example: Model of 2T-flash cell

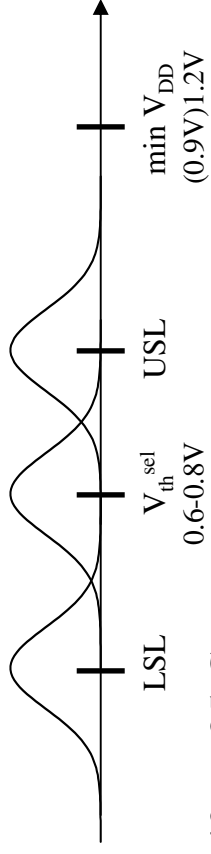
Model of select MOST – 0.18 μm with embedded FLASH



Select MOST: tunnel oxide 8nm
typical size 220/220 ÷ 400/300

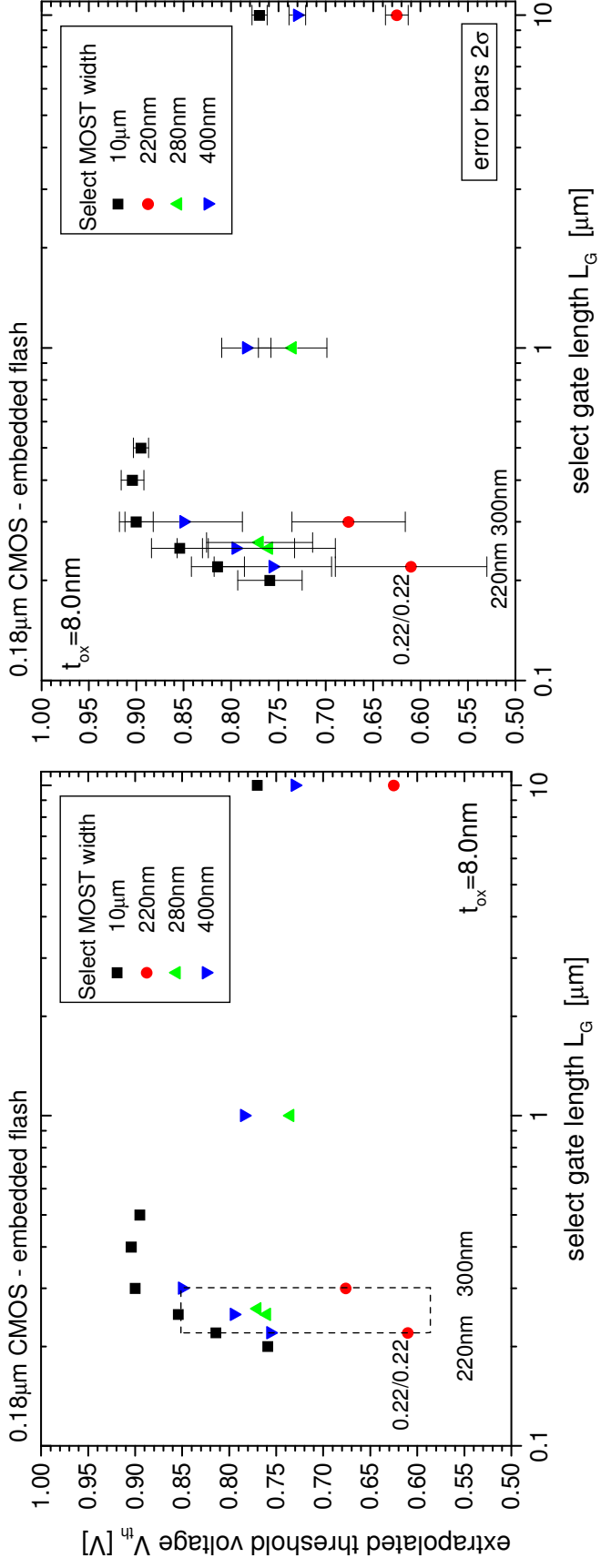
V_{th} tradeoff:

- 1) V_{th} too low \Rightarrow I_{off} leakage, leakage on inhibited cells
 \rightarrow program disturb
 \rightarrow HV charge-pump load
- 2) V_{th} too high \Rightarrow inability to operate with low V_{dd}



- (a) $V_{dd}=1.2\text{V}$ end-of-life of 1.5V battery
- (b) Future ICs: down to 0.9V

-40 ÷ +85°C



Small size select MOST $\rightarrow V_{th}$ spread
 Larger cell W/L \rightarrow smaller V_{th} spread, but larger FLASH memory area

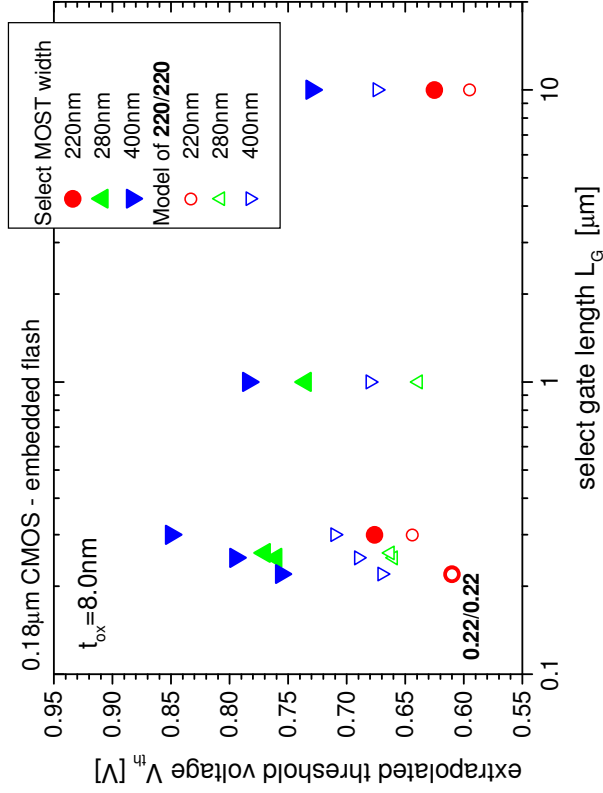
Note: V_{th} may be adjusted by process



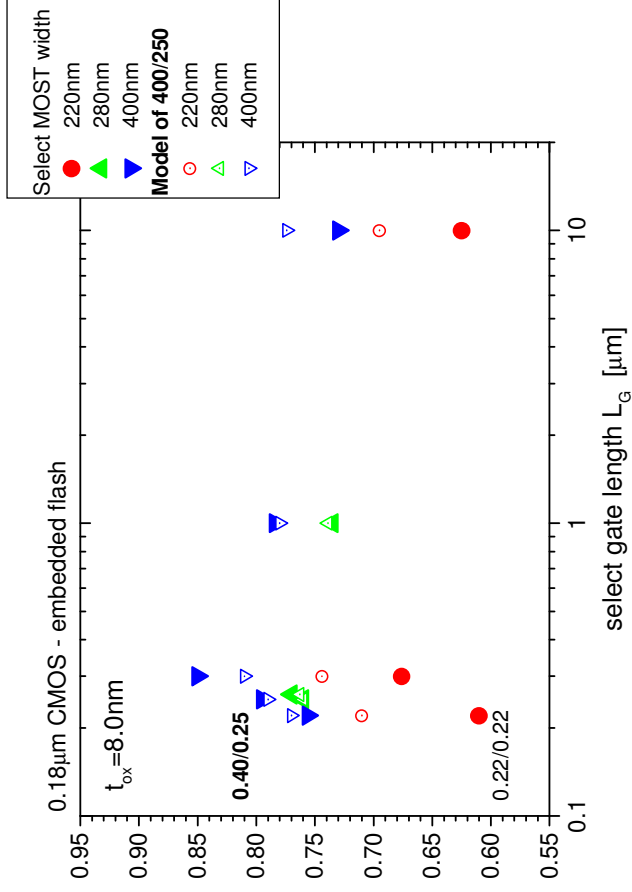
Accurate select MOST model with

- W/L dependence
 - T-dependence
 - matching parameters
- exceeds EKV 2.6 model capability.

⇒ Models for specific sizes W/L, with limited applicability possible:



dedicated 0.22/0.22 model



dedicated 0.4/0.25 model

Conclusion:

- Some challenges in EKV2.6 MOSFET modelling in low-power circuit design are reviewed.
- EKV3.0 behaves correctly and shows good accuracy in solving the reviewed problems.
- EKV2.6 → EKV3.0
for current most advanced and future EMM technologies.